In the Specification:

Please amend the second full paragraph on Page 6 (particularly lines 15-16) as follows:

In another aspect of the present invention, a method of forming a barrier rib of PDP includes the steps of forming a white paste layer on a glass substrate and forming a photosensitive black resist layer on the white paste layer, forming a photosensitive black resist pattern by patterning the photosensitive black resist layer, heating the photosensitive black resist pattern so that a wax component contained in the photosensitive black resist pattern diffuses inside the photosensitive black resist pattern, and removing a portion of the white paste layer failing to be covered with the photosensitive black resist pattern and plasticizing the photosensitive black resist pattern and the remaining photosensitive black resist pattern the remaining white paste layer.